

UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION

PATENT NO. : 6,709,881 B2
DATED : March 23, 2004
INVENTOR(S) : Yoshiaki HASEGAWA, et al.

It is certified that error appears in the above-identified patent and that said Letter Patent is hereby corrected as shown below:

On the Title Page of the Letters Patent and Column One;

Under section "(54)" and under column one, change " METHOD FOR
MANUFACTURING SEMICONDUCTOR AND METHOD FOR
MANUFACTURING SEMICONDUCTOR DEVICE " to – METHOD FOR
MANUFACTURING SEMICONDUCTOR LASER OPTICAL DEVICE –

MAILING ADDRESS OF SENDER:
McDermott Will & Emery LLP
600 13th Street, NW
Washington, DC 20005
USA

PATENT NO.
6,709,881

No. of add'l copies
@ 50¢ per page

}